Electronic Filing System (EFS) Data **Electronic Patent Application Submission USPTO Use Only**

EFS ID:

62493

Application ID:

Title of Invention:

10710023

LITHOGRAPHIC

SEMICONDUCTOR

MANUFACTURING USING A

MULTI-LAYERED PROCESS

First Named Inventor:

Philip Lamarre

Domestic/Foreign Application: Domestic Application

Filing Date:

2004-06-14

Effective Receipt Date:

2004-06-14

Submission Type:

Utility Patent Filing

Filing Type:

new-utility

Confirmation number:

4022

Attorney Docket Number:

20030146

Total Fees Authorized:

810.0

Payment Category:

Deposit Account

Deposit Account Number:

190130

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